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Crossbar Architecture Based on 2R Complementary Resistive Switching Memory Cell

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Abstract—Emerging non-volatile memories (e.g. STT-MRAM, OxRRAM and CBRAM) based on resistive switching are under intense R&D investigation by both academics and industries. They provide high performance such as fast write/read speed, low power and good endurance (e.g. $>10^{12}$) beyond Flash memories. However the conventional access architecture based on 1 transistor + 1 memory cell limits its storage density as the selection transistor should be large enough to ensure enough current for the switching operation. This paper describes a design of crossbar architecture based on 2R complementary resistive switching memory cell. This architecture allows fewer selection transistors, and minimum contacts between memory cells and CMOS control circuits. The complementary cell and parallel data sensing mitigate the impact of sneak currents in the crossbar architecture. We performed transient simulations based on two memory technologies: STT-MRAM and OxRRAM to validate the functionality of this design by using CMOS 65 nm design kit and memory compact models.

Keywords-Crossbar; Resistive Switching; complementary cell;

I. INTRODUCTION

Modern computing systems suffer from rising static power due to the high leakage currents, which increase exponentially following the fabrication node miniaturization of CMOS technology (e.g. <90 nm) [1]. According to ITRS 2011, the static power will start to play the major role of whole power consumption in the next years [2]. In order to relieve this power issue, emerging non-volatile memories (NVM) based on resistive switching are under intense R&D investigation by both academics and industries. Spin transfer torque magnetic random access memory (STT-MRAM) [3]; Conductive-Bridge RAM (CBRAM) [A-4] and Oxide Resistive RAM (OxRRAM) [A-5] are among the most promising technologies. They promise to provide much higher performances than Flash memory such as fast write/read speed, low power and good endurance (e.g. $>10^{12}$). Since 2009, a number of NVM pre-industrial prototypes [6-10] were presented and the commercial products should be available soon.

Even though these emerging NVM are based on different physics, they hold many common features. For instance, they are two terminal nanoscale devices; their resistances vary to present '0' and '1'; their memory cell are implemented at back-end of line (BEOL) process [A-6-10] etc. Thereby they use the

same access structure 1T (transistor)+ 1R (resistive memory) shown in Fig.1a, and then benefit the existing peripheral control circuits of Dynamic RAM (DRAM). However this structure presents some drawbacks: the transistor is normally much larger than the minimum size in order to obtain the sufficient current for fast memory cell switching; there are lots of large interconnects between CMOS circuits and memory cell due to the thick metals (e.g. M3). They make the density of these NVM technologies lower than Flash memory. For example, Fig.2b shows the 65 nm layout implementation of the conventional STT-MRAM access design. In order to get fast switching speed (e.g. 10 ns), the selection transistor should be large enough to ensure a high current (e.g. 100 μ A). The CMOS circuits impose definitively the density of STT-MRAM density instead of magnetic tunnel junction (MTJ) [A-11].

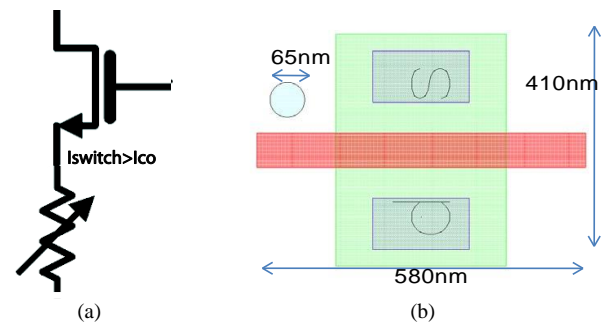


Figure 1. Conventional access approach based on 1 Transistor and 1 resistive memory cell. (a) Circuit diagram (b) Layout implementation at 65 nm; the size of selection transistor is about $56 F^2$.

Crossbar architectures were proposed to relax the density limitation of two-terminal resistive switching devices imposed by the CMOS [A-8-11]. There are only interconnects between CMOS circuits and memory cell on the edge of the crossbar array. A number of memory cells share the same selection transistor (see Fig.2). The cell area efficiency can be greatly improved, and the back-end process of NVM defines then the density instead of CMOS circuits. However, the conventional crossbar architectures suffer from sneak currents and low data access speed. The former is the most critical as the data sensing can be disturbed completely by the sneak currents. Moreover, there are parasitic resistances throughout a large-

scale crossbar array, which leads to lots of sensing errors [A-6-12]. These issues are difficult to surmount and few efficient design solutions addressing this issue have been reported previously in the literature. In this paper, we present a new crossbar architecture based on complementary resistive switching memory. Combining with parallel data sensing, the impact of sneak currents and parasite resistance can be mitigated to ensure the correct data sensing. In order to validate the functionality of this design, we performed transient simulations based on two memory technologies: STT-MRAM and OxRRAM by using CMOS 65 nm design kit and memory compact models.

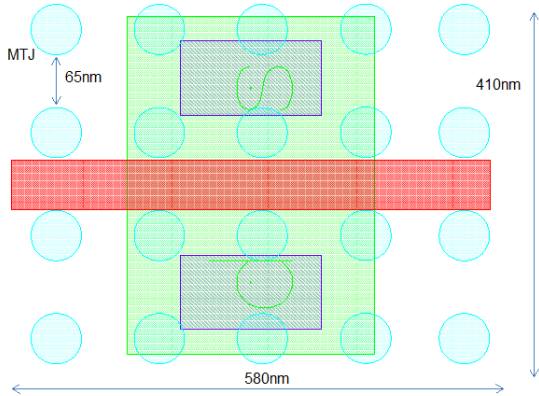


Figure 2. The layout implementation promises the best area efficiency, where the die area per storage bit is $2F^2$ and the selection transistor is shared by a number of MTJs associated in the same word (e.g. 4).

The rest of the paper is organized as follows. In the next section, we introduce the principles of STT-MRAM and OxRRAM. In Sections III, we describe the design details of complementary crossbar architecture. In Sections IV, we show the transient simulation of the crossbar architecture by using CMOS 65 nm design kit and compact models of the STT-MRAM and OxR-RAM. Finally, a discussion and concluding remarks are provided in section V.

II. EMERGING RESISTIVE SWITCHING MEMORIES

In this section, we introduce briefly the principles of STT-MRAM and OxR-RAM, which were studied as resistive switching memory cell in the proposed crossbar architecture.

A. STT-MRAM technology principle

Magnetic RAM (MRAM) promises stable non-volatility, fast write/read access speed and infinite endurance etc [A-2-3]. The MRAM storage element, MTJ nanopillar is mainly composed of three thin films: a thin oxide barrier and two ferromagnetic (FM) layers (see Fig.3a). As a result of the tunnel magnetoresistance (TMR) effect [A-12], the nanopillar resistance, R_P or R_{AP} , depends on the relative orientation, Parallel (P) or Anti-Parallel (AP), of the magnetization of the two FM layers. By using crystalline MgO barriers, the TMR ratio $= R_{AP} - R_P / R_P$ of MTJ nanopillars can reach more than 600% at room temperature [A-13-14]. This allows the state of

MTJs to be detected easily by CMOS sense amplifiers [A-15].

Spin transfer torque (STT) is one of the most promising switching approaches thanks to its high power efficiency and fast writing speed [A-4-5, 16]. This switching mechanism greatly simplifies the CMOS switching circuit, as only a bi-directional current is required. One time the current through the MTJ exceeds the critical current; the MTJ will switch its state (see Fig.3b). It opens the door to build up the first true universal memory with MRAM, which should provide both large capacity ($>$ Gigabit) and high speed ($<$ ns). Recent progress demonstrate perpendicular magnetic anisotropy (PMA) in CoFeB/MgO structures provides a high energy barrier E to deal with the issue of thermal stability of in-plane anisotropy, which also presents the advantages of low threshold current, high speed operation and high TMR ratios comparing with in-plane anisotropy.

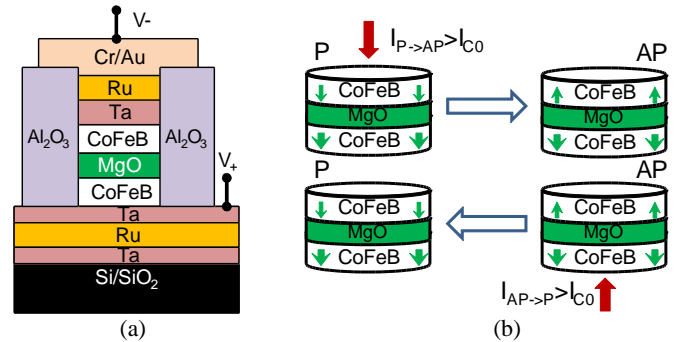


Figure 3. (a) Vertical structure of an MTJ nanopillar composed of CoFeB/MgO/CoFeB thin films. (b) Spin transfer torque switching mechanism: the MTJ state changes from parallel (P) to anti-parallel (AP) as the positive electron flow direction $I_{P \rightarrow AP} > I_{C0}$, on the contrast, its state will return as the negative electron flow direction $I_{AP \rightarrow P} > I_{C0}$.

B. OxRRAM technology principle

A large number of oxide-based materials showing a resistive switching are reported in the literature [Waser07] [Seo04] [Kim10]. Among them, metal oxides like HfO_2 , Ta_2O_5 , NiO , TiO_2 or Cu_2O are promising candidates due their compatibility with CMOS processes and high on/off resistance ratio. In its simplest form, resistive memory element relies on a Metal/Insulator/Metal (MIM) stack (Fig. 4) that can be easily integrated into Back-End Of Line (BEOL).

The MIM structure is generally composed of an active layer, usually a non-stoichiometric dielectric. The bipolar behavior is mainly due to an asymmetrical geometry of the electrode. In recent years, many studies have highlighted the good performances of non-stoichiometric HfO_x [Lee08-IEDM] films used as switching layer (also used in memristors demonstrated by Hewlett-Packard [Lee10]). Besides, an additional buffer layer, also called interface layer, such as Al_2O_3 or Ti may play an important role in the reliability and the reduction of the programming voltage [Lee08-IEDM] [Lee10].

OxRRAM technology is still in its ‘‘infancy’’ since the physics of resistance switching is not yet fully understood. So far, it is broadly accepted that the electro migration of oxygen vacancies plays a critical role in the resistance switching [Ahn107].

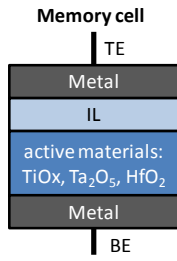


Figure 4. OxRRAM memory element stack overview.

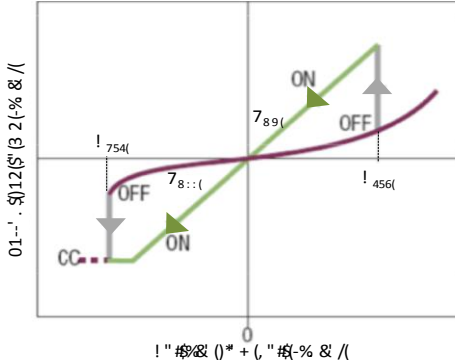


Figure 5. Typical I-V characteristic of a bipolar OxRRAM memory device.

After an initial electroforming process, the memory element may be reversibly switched between reset (high resistance) and set states (low resistance). Electroforming stage corresponds to a voltage-induced resistance switching from an initial very high resistance state (virgin state) to a conductive state. In the literature, unipolar, bipolar and non-polar electrical behaviors are reported. In the case of bipolar switching, addressed in this paper, bipolar voltage sweeps are required to switch the memory element (Fig. 5). Resistive switching in an OxRRAM element corresponds to an abrupt change between a High Resistance State (R_{HRS} or OFF state) and a Low Resistance State (R_{LRS} or ON state). This resistance change is achieved by applying specific threshold voltage to the structure (*i.e.* V_{SET} and V_{RESET}).

III. COMPLEMENTARY CROSS-BAR ARCHITECTURE

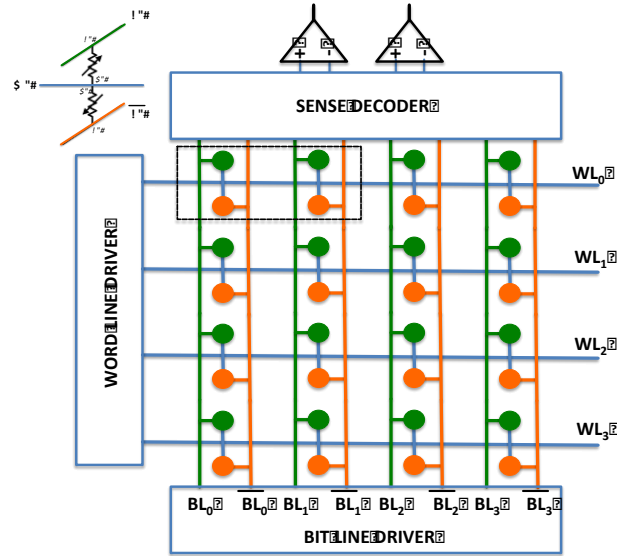


Figure 6: Proposed Cross Point architecture (4×2 words array with 2 bits word length). It includes three parts, a cross-point array of 2R cell for data storage, word line (left side) and bit line (bottom) driver and read circuits (top).

The cross point architecture is shown in Fig.6, which is composed of three parts: a memory array for data storage, bit line and word line drivers, read decoder and sense amplifiers for read operation. The operating mechanisms will be detailed in the following subsections:

A. Cell structure and operation

Every cell is composed of two resistive switching elements (2R) as shown in inset of Fig.6. For every cross-point, a common word line (WL) is connected to the bottom electrode (BE) of both resistive switching elements while their top electrode (TE) are respectively connected to bit-line (BL) and complementary bit-line (\overline{BL}). Cell programming operation are performed in two phases, as follow:

- 1st Phase: For the selected word, the common WL is grounded and all the bit-line and complementary bit-line are biased to V_{DD} and a current flow from top to bottom electrode, to set the resistive elements to a low resistance state (R_{LRS}) as shown Fig.7.a.
- 2nd Phase: For the selected word, the common WL is set to V_{DD} while BL and \overline{BL} are biased to complementary value in order to selectively reset (high resistance state – R_{HRS}) either the top resistive element or the bottom resistive element. In this case the current flows from the bottom to the top electrode. At the end of the programming operation both elements have opposite resistance state. Fig.7.b.
- All unselected word-line and bit-line are biased to $V_{DD}/2$ to keep resistive elements unchanged. As shown Fig.7.c two sub-array conditions are found for the unselected cells. One sub-array that share bit-line or word-line with the selected word see a biasing of $V_{DD}/2$ and all the other cells see a biasing of 0 volt.

The read operation is performed through a differential sensing of the bit-line and complementary bit-line and will be described in the sense-amplifier sub-section.

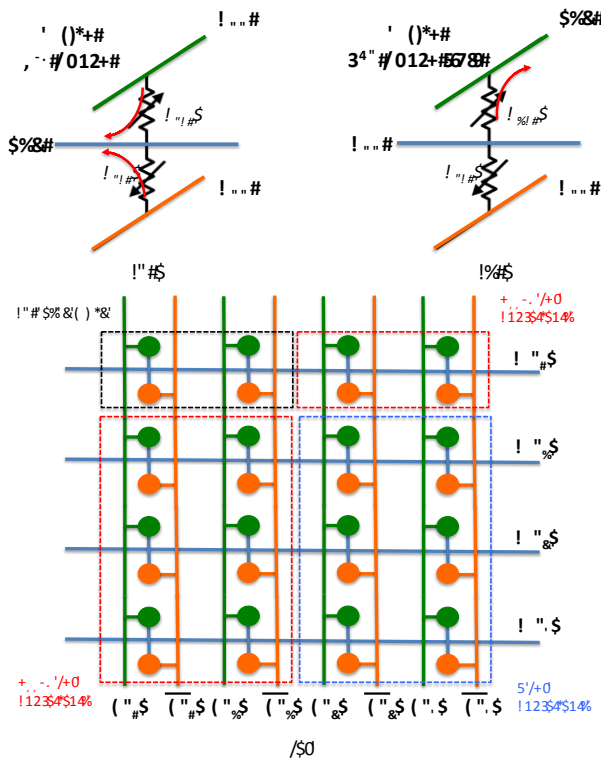


Figure. 7. Operation process in the cross point array: (a) For the selected word, the $WL=gnd$ and both bit-line are biased to V_{DD} (write 1st phase). (b) For the selected word, $WL=V_{DD}$ while the bit-line are set to opposite values (write 2nd phase). (c) For the unselected words, both the word-lines and the bit-lines are biased to $V_{DD}/2$ to ensure that unselected resistive elements do not set or reset.

B. Array architecture

As shown in Fig.6, the array is divided in M word per word line (e.g. 2). Each word is composed of N bits (e.g. 2). There is one driver circuit associated with each word-line and bit-line to ensure the proper biasing conditions for all modes of operations (write, read, unselected). A read decoder connects the N sense-amplifier to the selected word during the read phase.

C. Driver circuit

When dealing with bipolar resistive switching element, one may be able to apply bipolar voltage between the top and bottom electrode as well as bidirectional current to properly achieved programming phase. Moreover, as described in previous sub-section, voltage and current must remain below threshold to do not changed resistance value of unselected cell. To achieve this set of conditions, drivers have to be connected to the bit-line and the word-line. Row & column decoders together with the control logic activate the drivers. Decoder and control logic are similar to other well-known memory circuits and are not described here. A driver is composed (Fig.8) of one PMOS to connect a line to V_{DD} and two NMOS to connect a line to gnd or $V_{DD}/2$. It is important to note that the driver sizing is crucial to control the current and voltage levels

applied to the cell, which is a mandatory step to properly determine the R_{HRS} and R_{LRS} values.

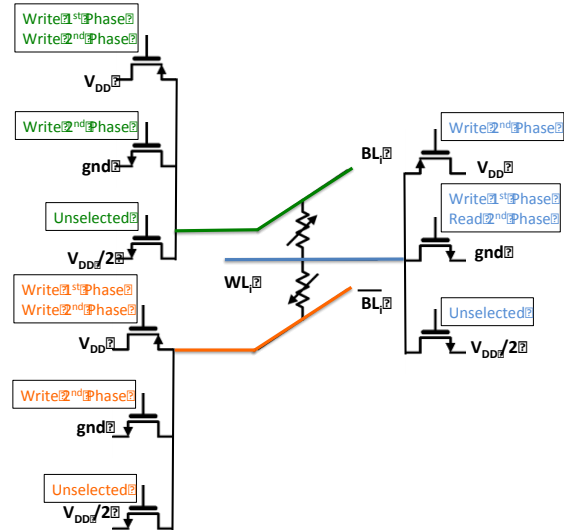


Figure. 8. Bit-line and word-line driver description. Two NMOS and one PMOS are connected to each bit-line and word-line to ensure correct biasing during all phases of operation (Write 1st and 2nd phase, Read 1st and 2nd phase).

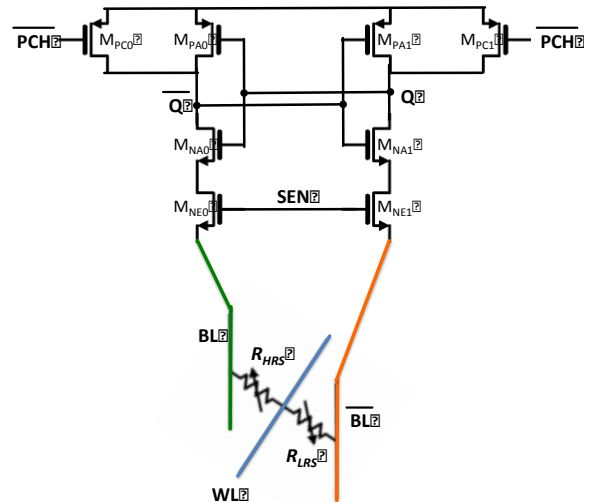


Figure. 9: Pre-Charged Sense Amplifier (PCSA) for data sensing: M_{PC0} and M_{PC1} serve to pre-charge the bit-line to V_{DD} ; M_{PA0} , M_{PA1} , M_{NA0} and M_{NA1} constitute the amplifier; M_{NE0} and M_{NE1} play the role of "Enable".

D. Sense amplifier definition

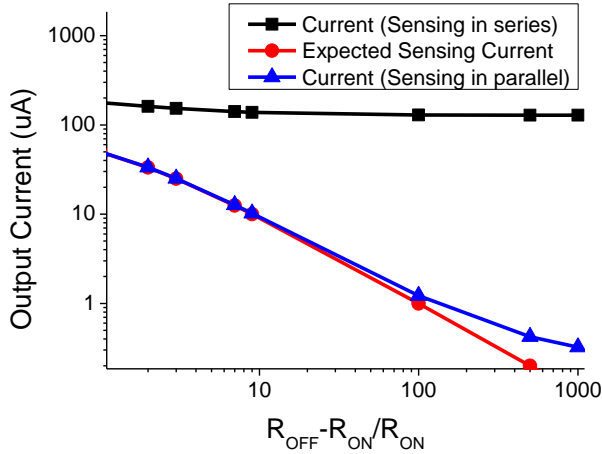
The read operation of data stored in *cross-point* resistive switching memory is currently one of the major challenges to develop this approach. Indeed, *sneak path* or *destructive read* with CRS element [S Tappertzhofen11] are a strong limit to develop this type of architecture. Moreover, the resistance ratio (R_{HRS}/R_{LRS}) and the process variations have to be considered when designing a sense solution. A sense amplifier performing with high reliability is then required. Fig.9 shows a pre-charge based sense amplifier (PCSA), which has demonstrated the best tolerance to different sources of variation [A-13], while keeping high speed and low power. In this SA, the read operation is performed in two phases:

1st Phase: The SA is first connected to the bit-line of the selected word with *SEN* set to ‘1’ and the circuit is pre-charged with *PCH* equals ‘0’.

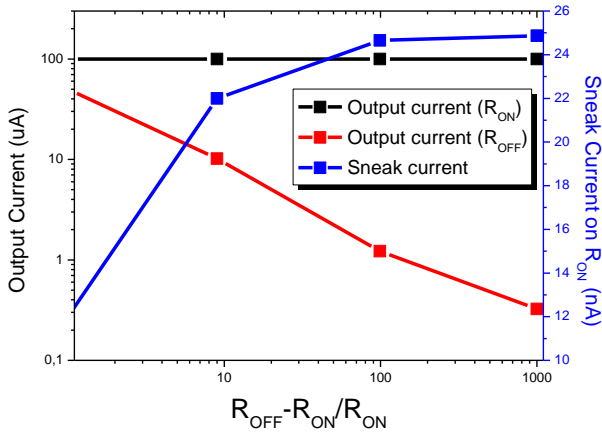
2nd Phase: The data stored in the 2R cell can be evaluated to logic level at the output *Q* as *PCH* is changed to ‘1’ and *WL* is pulled down to ‘0’.

E. Sneak current mitigation

As mentioned previously, this structure is designed to mitigate the impact of sneak currents and parasite resistance. Thanks to the complementary configuration in the memory cell, there are always the same numbers of unselected transistors and the same distance of wire connection (see Fig.7), this balanced structure allows the impact of parasite resistance to be neglected during data sensing.



(a)



(b)

Figure. 10. (a) The comparison of expected current value, sensing current in series and sensing current in parallel VS the R_{OFF}/R_{ON} ratio (b) Parallel sensing currents to address R_{OFF} and R_{ON} in the crossbar array, the sneak currents in unaddressed R_{ON} memory cell VS the R_{OFF}/R_{ON} ratio.

Parallel data sensing allows the impact of sneak currents to be mitigated as all the bit lines are set to the same voltage potential. We performed a simple simulation of 4×4 crossbar

array and evaluated the impact of sneak currents on data sensing for different architectures. The worst case is implemented, where the cell to address is R_{OFF} and all the other cells are R_{ON} . The sensing of this cell suffers from the most important impact of sneak current. R_{ON} is fixed to 10K ohm; the parasite resistance in each wire (BLs and WLs) connected is set to 10 ohm. Fig.10a shows that the current value for sensing in series (black square curve) is much higher than the expected current value (red point curve). This confirms that the sneak currents can perturb completely the sensing operation if there are no any mitigation solutions. However, the current value for sensing in parallel (blue triangle curve) equals nearly to the expected current value as the R_{OFF}/R_{ON} is lower than 10. This can be explained by the reduction of sneak currents in each memory cell (blue square curve) and the decreasing of sensing current difference between R_{OFF} and R_{ON} , as shown in Fig.10b.

IV. VALIDATION WITH BIPOLAR OXRRAM AND STT-MRAM MEMORY CELL

The aim of this section is to present the architecture validation with array simulation on both NVM technologies by using compact models and CMOS 65 nm design kit. In the following, we describe briefly the compact models. Transient simulation of the proposed architecture with STT-MRAM and OxRRAM are then presented.

A. Resistive Memory Cell modeling

1) STT-MRAM compact model

A CoFeB/MgO/CoFeB STT-MTJ compact model has been recently developed based on the physical theories and experimental measurements of perpendicular magnetic anisotropy (PMA) MTJ [A-16]. It integrates the physical models of static, dynamic and stochastic behaviors. The major parameters are shown in the Table.I.

The static behaviors of STT switching in PMA MTJ is mainly based on the calculation of threshold or critical current I_{c0} , which can be expressed by the Eq.A-2 [A-17],

$$I_{c0} = \alpha \frac{\gamma e}{\mu_B g} (\mu_0 M_S) H_K V = 2\alpha \frac{\gamma e}{\mu_B g} E \quad (A-2)$$

where E is the barrier energy (see also Eq.1), α is the magnetic damping constant, γ is the gyromagnetic ratio, e is the elementary charge, μ_B the Bohr magneton, V the volume of the free layer and k_B the Boltzmann constant.

The switching dynamics of STT in PMA MTJ is presented in [A-18] and Eq.A-3 shows the dependence of switching current I_{write} value with the duration.

$$\frac{1}{\langle \tau \rangle} = \left[\frac{2}{C + \ln\left(\frac{\pi^2 \xi}{4}\right)} \right] \frac{\mu_B P_{ref}}{em(1 + P_{ref} P_{free})} (I_{write} - I_{c0}) \quad (A-3)$$

where $C \approx 0.577$ is the Euler's constant, $\xi = E/k_B T$ the activation energy in units of $k_B T$, P_{ref} , P_{free} the tunneling spin polarizations of the reference and free layers, we assume that $P_{ref} = P_{free} = P$ for this compact model, m is the magnetic moment of free layer.

Fig.11 shows the transient simulation of this compact model, which could also verify the agreement of the dynamic

behavior between physical models and experimental measurements. We found that the switching delay is inversely proportional to the writing current as described in Eq. A-3.

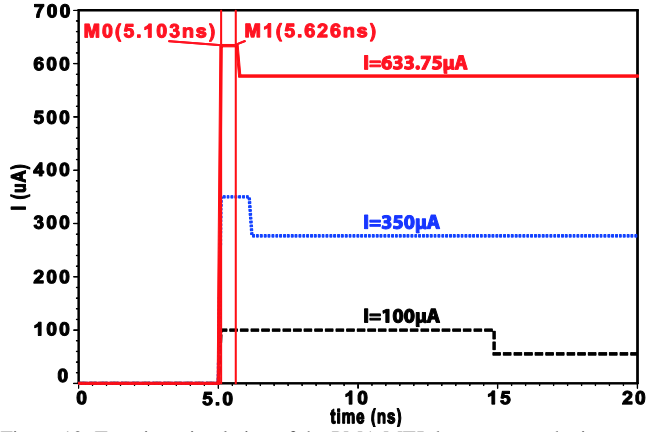


Figure.10. Transient simulation of the PMA MTJ demonstrates the integration of dynamic model and helps us to evaluate the tradeoff between CMOS die area and switching speed.

TABLE I

PARAMETERS AND VARIABLES PRESENT IN THE FITTING FUNCTIONS

Parameter	Description	Default Value
Area	MTJ surface	65 nm x 65 nm
TMR(0)	TMR ratio with 0 V _{bias}	120%
V	Volume of free layer	surface x 1.3 nm
R·A	Resistance-area product	10 Ωµm ²
V _{write}	Writing voltage	1.5 V
V _{read}	Reading voltage	1.2 V
Jc0	Critical current density	5.7 x 10 ⁵ A/cm ²

2) OxRRAM Compact Model

The proposed OxRRAM modeling approach relies on a physical model accounting for both set and reset operations in bipolar resistive switching devices. In considering electric field-induced migration of oxygen vacancies within the switching layer, the model enables continuously accounting for both set and reset operations into a single master equation in which the resistance is controlled by the diameter of the conduction pathways (ϕ):

$$\frac{d\phi}{dt} = \frac{\phi_m}{\tau} \cdot \frac{E a q \alpha V_c}{k_b T} \cdot e^{-\frac{E a q \alpha V_c}{k_b T}} - \frac{\phi}{\tau} \cdot e^{-\frac{E a q \alpha V_c}{k_b T}} \quad (1)$$

In equ. 1, τ represents the creation/destruction rate, $E a$ the activation energy and V_{Cell} the cell voltage. Based on this expression, the cell current can be expressed as a function of the size of this conductor path:

$$I_{Cell} = \frac{V_{Cell}}{L} \cdot \frac{\pi}{4} \cdot \left(\phi^2 \cdot (\sigma_{LRS} - \sigma_{HRS}) + \phi_{max}^2 \cdot \sigma_{HRS} \right) \quad (2)$$

Where σ_{LRS} and σ_{HRS} represents the conductivity in the Low Resistance State and the High Resistance State. This physical model demonstrates its flexibility to match the switching voltages, the levels current and the dynamics dependence on various technologies [NVMTS11][IDT11]. This last point is a key point to perform a realistic circuit analysis.

In this way, the model carte has been adjusted to fit at the behavior of the most aggressive component from literature: Set/Reset voltage below 1V [Cagli11-IEDM] and programming time around 10ns [Lee08-IEDM]. Table I summarizes the cell operation parameters for very short programming pulse.

TABLE I. CELL OPERATION PARAMETERS.

	V _{TE} (V)	V _{BE} (V)	STATE
SET (Write)	0.8@10ns	0	ON→OFF
RESET (Erase)	0	-0.8V@10ns	OFF→ON
Read	<0.4@10ns	Sensing	ON or OFF

B. Architecture simulation

The aim of this section is to validate the functionality of the architecture for both technologies

1) STT-MRAM array simulation

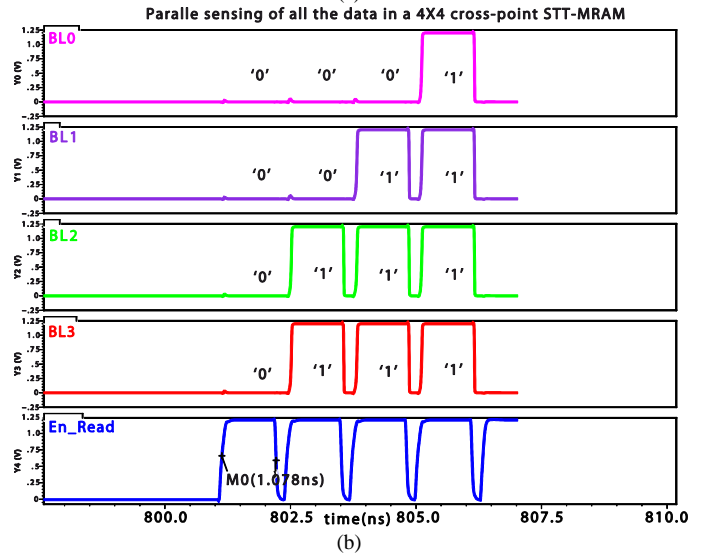
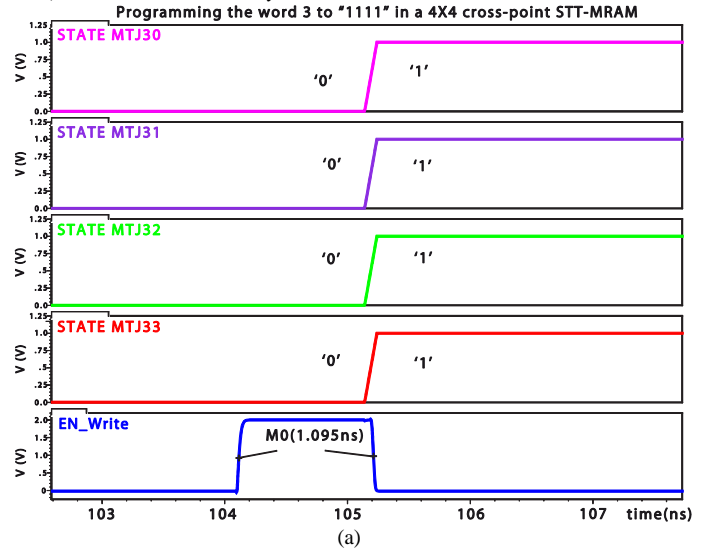


Fig. 11. (a) Configuration of the small crossbar array (b) Parallel sensing of a 4x4 cross-point array within ~5ns (~1.2ns/word).

Fig. 11 (a) and (b) demonstrate the mixed simulation of parallel writing /reading for this 4x4 cross-point resistive

switching memory and confirm the expected operations shown in the section III. For instance, it takes only one cycle of switching duration, ~ 1.1 ns driven by the signal “EN_Write” to program a word to “0000” or “1111”. Thanks to the fast computing speed of the PMA MTJ compact model, the simulation of this 4×4 cross-point memory can be performed in ~ 30 minutes in a medium performance CAD server (two Xeon: 4-Core, 12MB cache, 2.4GHz and 8GB 1.3GHz RAM).

In order to keep the same data read access speed with that of data programming, the pulse duration of “En_Read” (see also Fig.6) is set to ~ 1 ns. The word address changes between two “En_Read” pulses during ~ 100 ps and the data stored in this 4×4 cross-point STT-MRAM can be detected word by word in ~ 5 ns. It is noteworthy that the sensing speed can be accelerated up to ~ 200 ps/word [20], which would lead to an asymmetric delay between the programming and reading operations. Nevertheless, this asymmetric delay is nearly ubiquitous in non-volatile memories and it may present some advantages in terms of power and access speed as the non-volatile memories are read more frequently than programmed.

2) OxRRAM array simulation

To validate the efficiency of the proposed architecture with the OxRRAM technology, an array composed of 32 word-lines of 2 words of 16 bits including line drivers and PCSAs, as shown Fig.11, is fully simulated. Moreover, as depicted in the inset Fig. 11, WL and BL resistance and capacitance are modeled through RC element distributed all over the array.

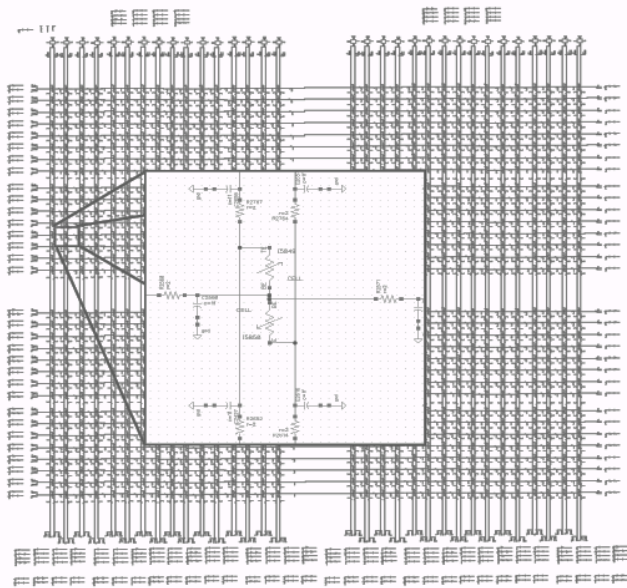


Figure 11: Schematic of the full array simulated to validate the efficiency of the proposed architecture with OxRRAM technology.

The simulation is divided in two: a write phase, where all the words in the array are successively written with the pattern given Fig.12, followed by the selective read of the top-left word in the array. The write time is set to 20ns with 10ns by phase. The read time is also set to 20ns with 10ns pre-charge and 10ns to generate a logic value on the output. It is important to note that the write and read timing value gives a strong

margin versus the capability of the PCSA, as depicted on simulation results given Fig.13.

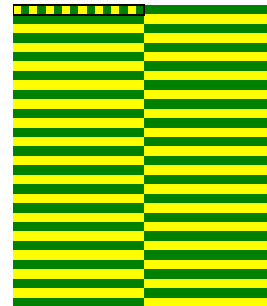


Figure 12: Topologic representation of the pattern store in the array, yellow color stand for ‘0’ and green for ‘1’. The pattern used is a “checkerboard” per word. The reading phase targets the top-left word (word₀₀). Scrambling aspects are not taken into account.

The Fig.13 gives an overview of the simulation results, with the writing phase of: a cell in the selected word, a cell in an unselected word, a cell in a unselected bit-line and of a read phase.

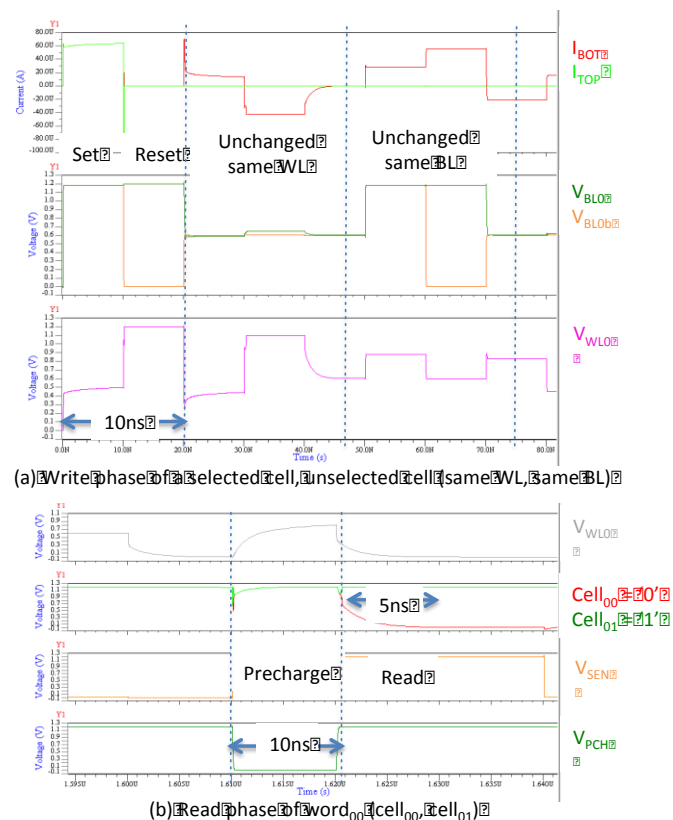


Figure 13: Simulation results with (a) write phase of a selected cell, behavior of an unselected cells and read phase of Word₀₀ (cell₀₀ and cell₀₁)

The Fig.13(a) shows the behavior of the cell₀₀ while in a first phase the cell is programmed (cell both OxRRAM elements are set and only top OxRRAM element is reset). Moreover, this simulation results validates the fact that the cell₀₀ remains unchanged, during the write phase of the second word (word₀₁) on the same word-line (WL_0) or during the write phase of the first word (word₁₀) of the second word-line (WL_1)

sharing the same bit-lines. The Fig.13(b) validates the ability of the architecture to successfully read in parallel a full word (word₀₀) with typically cell₀₀=’0’ and cell₀₁=’1’.

V. CONCLUSION

This paper describes a generic design of crossbar architecture based on 2R complementary resistive switching memory cell. This architecture allows fewer selection transistors, and minimum contacts between memory cells and CMOS control circuits. The complementary cell and parallel data sensing mitigate the impact of sneak currents in the crossbar architecture. This generic architecture is implemented on two emerging technologies STT-MRAM and OxRRAM. Compact model of STT-MRAM and OxRRAM resistive elements are developed to simulate full array on both technologies. Simulation results of a 4×4 STT-MRAM array and a 32×32 OxRRAM array (16 bits word length) validate successfully the functionality of the proposed architecture using CMOS 65nm design kit.

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